



04-10-01 0280 #2

TRANSMITTAL OF FORMAL DRAWINGS

Docket No.
FIS920000396US1 / I30-0001

In Re Application Of: Mukesh Khare et al.

| Serial No. | Filing Date | Batch No. | Examiner | Art Unit |
|------------|-------------|-----------|----------|----------|
| 09/809,663 | 3/15/2001 | | | |

Invention:

METHOD FOR IMPROVED PLASMA NITRIDATION OF ULTRA THIN GATE DIELECTRICS

Address to:

Assistant Commissioner for Patents
Washington, D.C. 20231

Transmitted herewith are:

9 sheets of formal drawing(s) for this application.

Each sheet of drawing indicates the identifying indicia suggested in 37 CFR Section 1.84(c) on the reverse side of the drawing.

Signature

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Dated: April 3, 2001

I certify that this document and attached formal drawings are being deposited on 4/3/2001 with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.

Signature of Person Mailing Correspondence

Jessica L. Walsh

Typed or Printed Name of Person Mailing Correspondence